

APPLICANT'S ART CITATION (Use several sheets if necessary)		Application 10/042,790		OFCS File No. P/189-166			
		Applicant Jose Ignacio Bueno RUIZ et al.					
		Filing Date January 8, 2002		Group Art Unit 2836			
U.S. PATENT DOCUMENTS							
Examiner Initial	Document Number	Date MM-YYYY	Name	Class	Sub-class	Filing Date If Appropriate	
<i>h</i>	US-5,282,709	02-1994	Chaput et al.	411	433		
<i>h</i>	US-4,941,790	07-1990	Kim	411	432		
<i>h</i>	US-5,722,709	03-1998	Lortz et al.	294	86.4		
<i>h</i>	US-5,160,233	11-1992	McKinnis	411	433		
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FOREIGN PATENT DOCUMENTS							
	Document Number	Date MM-YYYY	Country	Class	Sub-class	Translation	
						Yes	No
<i>h</i>	WO 00/17051	03-2000	PCT	B64G	1/64	X (Abstract Only)	
<i>h</i>	07187094	07-1995	Japan	B64G	1/64	X (Abstract Only)	
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)							
Examiner	<i>h Jackson</i>		Date Considered 1-23-04				
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